103 年度民專訴字第 95 號判決附表

編號	國家	專利號	申請號	專利名稱	專利權登記名義人	A 欄	B 欄
1.	US	6830598	10/254,057	Molten braze coated superabrasive particles and associated methods	Sung; Chien-Min	◎	
2.	US	7261752	10/627,441	Molten braze-coated superabrasive particles and associated methods	Sung; Chien-Min	◎	
3.	US	8491358	12/650,782	Thin Film Brazing of superabrasives tools	Sung; Chien-Min	◎	
4.	US	8104464	12/463,897	Brazed diamond tools and methods for making the same	Sung; Chien-Min	◎	
5.	US	6159286	09/185,930	Process for controlling diamond nucleation during diamond synthesis	Sung; Chien-Min	◎	◎
6.	US	8298048	13/281,215	CMP Pad Dresser With Oriented Particles And Associated Methods	Sung; Chien-Min	◎	◎
7.	US	7771498	11/436,881	Superabrasive tools having improved caustic resistance	Sung; Chien-Min	◎	◎
8.	US	7749050	12/346264	Pad Conditioner Dresser	Sung; Chien-Min	◎	◎

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9.	US	8298043	12/831158	Pad Conditioner Dresser	Sung; Chien-Min	◎	◎
10.	US	8142261	11/606,365	Methods for enhancing chemical mechanical polishing pad processes	Sung; Chien-Min	◎	◎
11.	US	8393938	12/267,172	CMP Pad Dressers	Sung; Chien-Min	◎	◎
12.	US	8449357	12/246,253	Polymeric Fiber CMP Pad and Associated Methods	Sung; Chien-Min	◎	◎
13.	US	7393264	11/657,394	Tools for polishing and associated methods	Sung; Chien-Min	◎	◎
14.	US	7494404	11/825,518	Tools for polishing and associated methods	Sung; Chien-Min	◎	◎
15.	US	8398462	12/389,922	CMP PADS AND METHOD OF CREATING VOIDS IN-SITU THEREIN	Sung; Chien-Min	◎	◎
16.	US	7241206	11/357,712	Tools for polishing and associated methods	Sung; Chien-Min	◎	◎
17.	US		13/407,634	Brazed Diamond Tools and Methods for Making the Same	Sung; Chien-Min	◎	

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18.	US		13/416,201	Brazed Diamond Tools and Methods for Making the Same	Sung; Chien-Min	◎	
19.	US		13/633,082	Brazed Diamond Tools and Methods for Making the Same	Sung; Chien-Min	◎	
20.	US		13/644,790	Brazed Diamond Tools and Methods for Making the Same	Sung; Chien-Min	◎	
21.	US		13/113,779	Nanoparticle Radiator Devices and Methods	Sung; Chien-Min	◎	
22.	US		13/153,176	Brazed Diamond Tools and Methods for Making the Same	Sung; Chien-Min	◎	
23.	US		13/797704	COMPOSITE CONDITIONER AND ASSOCIATED METHODS	Sung; Chien-Min		
24.	US		13/802112	CMP PAD DRESSER HAVING LEVELED TIPS AND ASSOCIATED METHODS	Sung; Chien-Min		
25.	US	8974270	13/479148	CMP PAD DRESSER HAVING LEVELED TIPS AND ASSOCIATED METHODS	Sung; Chien-Min		
26.	US	8920214	13/531,409	DUAL DRESSING SYSTEM FOR CMP PADS AND ASSOCIATED METHODS	Sung; Chien-Min	◎	◎

編號	國家	專利號	申請號	專利名稱	專利權登記名義人	A 欄	B 欄
27.	TW	I400143	098127826	研磨工具及其製作方法	宋健民	◎	
28.	TW	I331066	096117531	具改良之抗腐蝕性的超研磨工具及其製造方法	宋健民	◎	◎
29.	TW	I412428	098137727	拋光墊調整修整器	宋健民	◎	◎
30.	TW	I440527	100115538	具有混合修整功能的化學機械拋光墊修整器及相關方法	宋健民	◎	◎
31.	TW	M465659	102206277	化學機械研磨修整器	宋健民		
32.	TW	I412429	097104770	研磨工具及其相關方法	宋健民	◎	◎
33.	TW	I417166	101127427	研磨工具及其相關方法	宋健民	◎	◎
34.	TW	I388396	098105591	於內部原位生成空隙的拋光墊及其方法	宋健民	◎	◎
35.	TW	M446063	101215212	化學機械研磨修整器	鉅鑽公司		
36.	TW		101112625	組合式修整器及其製法與化學機械平坦化應用	鉅鑽公司		

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37.	TW		099146262	化學機械拋光系統及其相關方法	宋健民	◎	◎
38.	TW	I487019	101118288	具有平坦化尖端之化學機械研磨墊修整器及其相關方法	宋健民		
39.	TW		102118308	具有平坦化尖端之化學機械研磨墊修整器及其相關方法	宋健民		
40.	TW		101123918	化學機械研磨墊之雙重修整系統及相關方法	宋健民	◎	◎
41.	US	7658666	11/786,426	Superhard cutters and associated methods	Sung; Chien-Min	◎	◎
42.	US	7762872	11/560,817	Superhard cutters and associated methods	Sung; Chien-Min	◎	◎
43.	US	6659161	09/687,444	Molding process for making diamond tools	Sung; Chien-Min	◎	◎
44.	US	6814130	10/002,395	Methods of making diamond tools using reverse casting of chemical vapor deposition	Sung; Chien-Min	◎	◎
45.	US	6969313	10/666,701	Cast diamond tools and formation thereof by chemical vapor deposition	Sung; Chien-Min	◎	◎

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46.	US	7095157	10/984,341	Cast diamond tools and formation thereof by chemical vapor deposition	Sung; Chien-Min	◎	◎
47.	US	7258708	11/026,544	Chemical mechanical polishing pad dresser	Sung; Chien-Min	◎	◎
48.	US		13/794164	CMP PAD DRESSERS WITH HYBRIDIZED ABRASIVE SURFACE AND RELATED METHODS	Sung; Chien-Min		
49.	US		13/793,871	Methods of Bonding Superabrasive Particles in an Organic Matrix	Sung; Chien-Min	◎	◎
50.	US		12/706,950	CVD Diamond Superabrasive Tools and Associated Methods	Sung; Chien-Min	◎	◎
51.	US		13/846740	CMP PAD CONDITIONERS WITH MOSAIC ABRASIVE SEGMENTS AND ASSOCIATED METHODS	Sung; Michael, Sung; Chien-Min		
52.	TW	I264345	094147166	化學機械研磨修整器	宋健民	◎	◎
53.	TW	I355986	096143399	超硬切割裝置及其製法	宋健民	◎	◎
54.	TW	I463552	097145089	在修整化學拋光墊時的檢診方法及其相關系統	宋健民	◎	◎

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